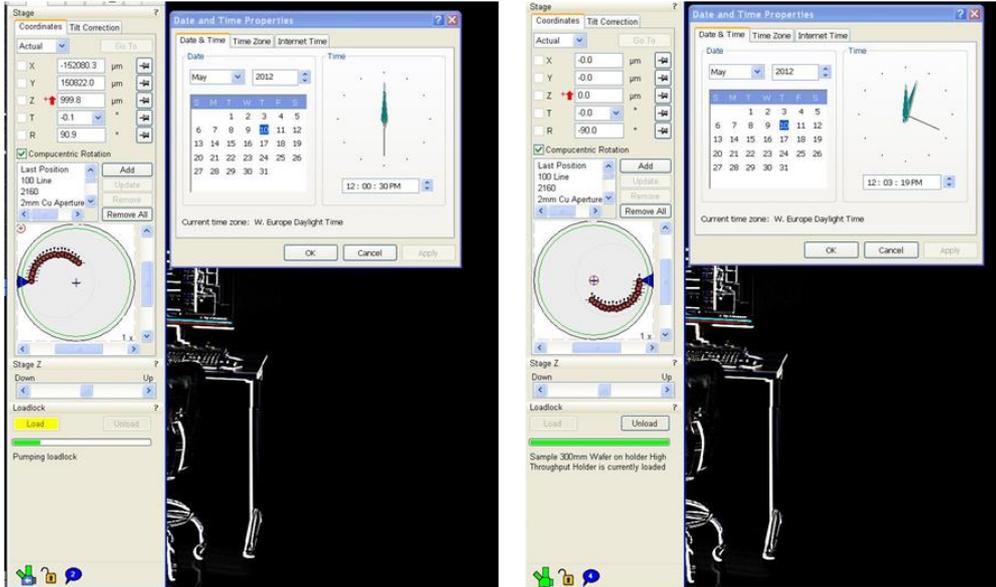


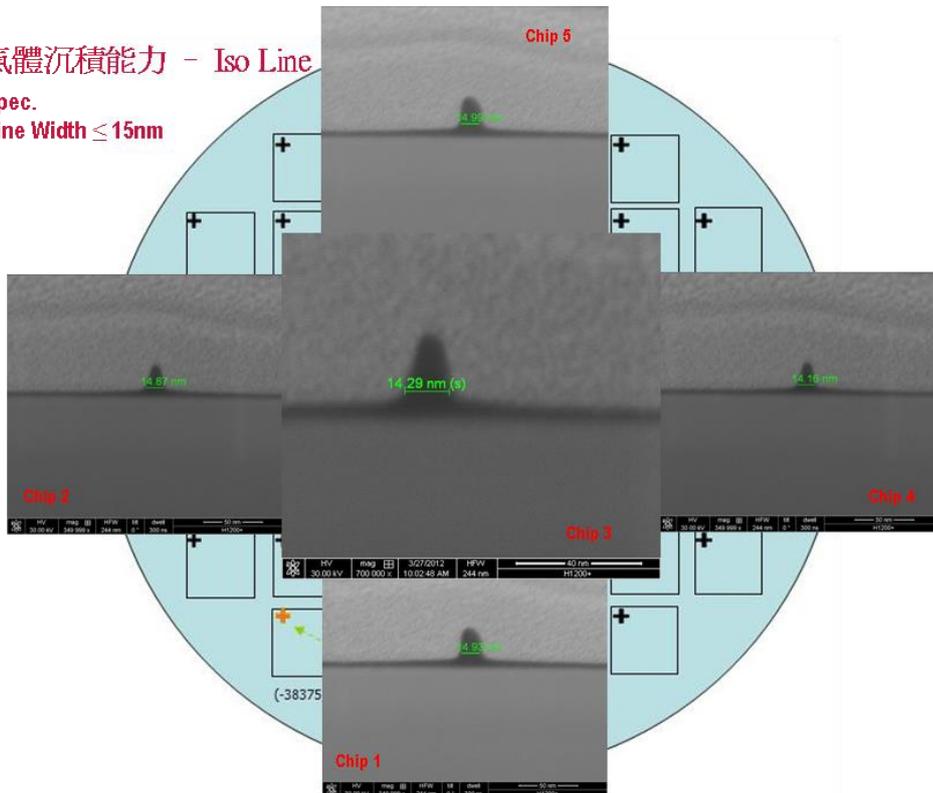
# 聚焦電子束系統技術資料

樣品腔體載入時間  $\leq 5\text{mins}$

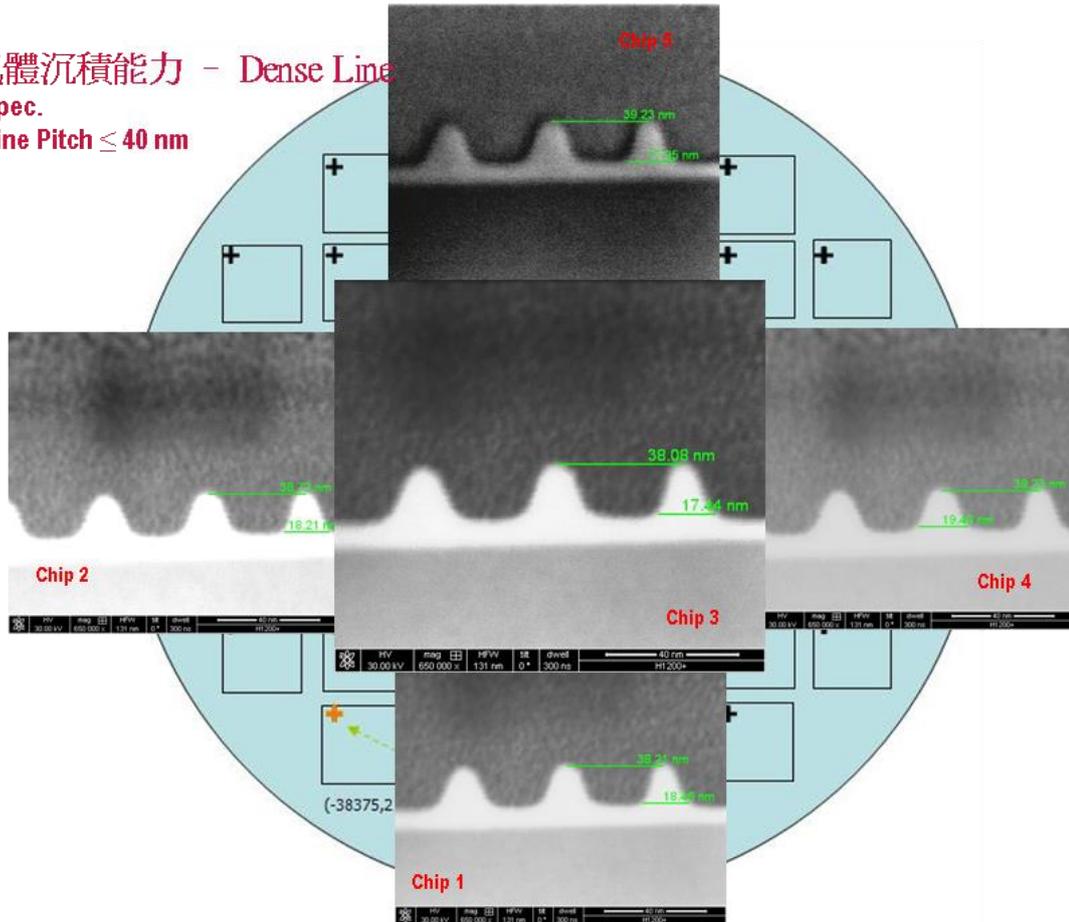
Total loading time 02:41 < 5mins



- 氣體沉積能力 - Iso Line Spec.  
Line Width  $\leq 15\text{nm}$

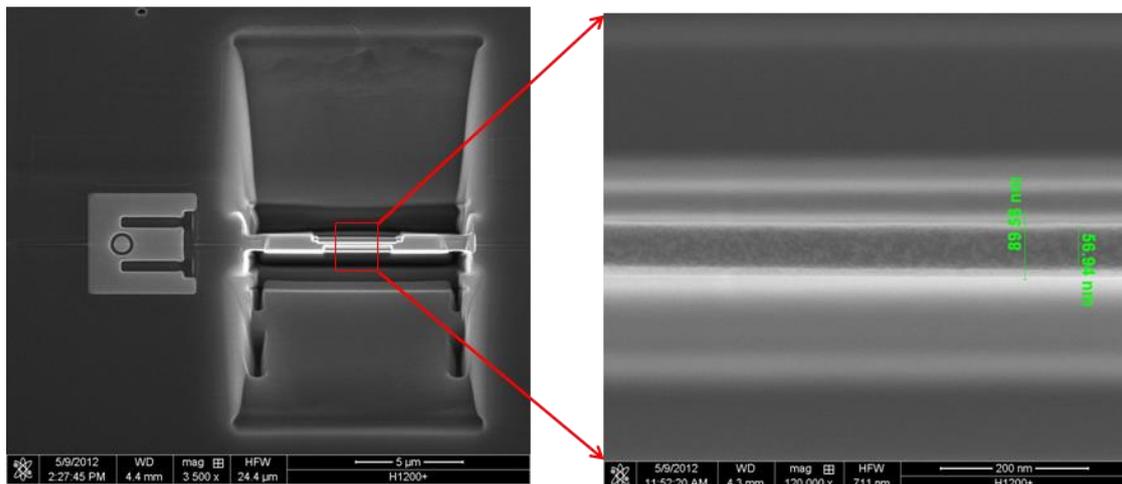


- 氣體沉積能力 - Dense Line  
Spec.  
Line Pitch  $\leq 40$  nm



- 自動切割TEM厚度與精準度

Spec.  
厚度  $\leq 100$  nm  
精確度  $\leq 30$  nm



Thickness measurement:  $(89.85 + 56.94) / 2 = 73.395$  nm  $< 100$  nm